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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Inventor: Nimmakayala, Pawan Kumar

App. No.: 10/735,110 GPAU: 2851

Filing Date: December 12, 2003 Examiner: (unassigned)

Dkt. No.: P122-64V58 Conf. No.: 1928

For: Magnification Correction Employing Out-Of-Plane Distortion
of a SubstrateINFORMATION DISCLOSURE STATEMENT

Mail Stop AMENDMENT
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

The following information is submitted in compliance with Applicants' duty of disclosure and pursuant to 37 C.F.R. § 1.56, § 1.97 and § 1.98. The undersigned brings the patents, publications, applications or other information identified in the attached:

Form(s) PTO/SB/08A and/or PTO/SB/08B or PTO/1449
 Other:

to the Examiner's attention in the above-identified application. It is respectfully requested that the cited information be expressly considered during the prosecution of this application, and the references be made of record therein and appear among the "references cited" on any patent to issue therefrom.

This Information Disclosure Statement is being filed:

before the mailing date of a first Office action on the merits or before the mailing date of a first Office action after the filing of a request for continued examination under § 1.114. Therefore, no fee is believed required.

Applicants do not believe that any additional fees are due, but if the Commissioner believes additional fees are due, the

Commissioner is hereby authorized to charge any fees which may be required, or credit any overpayment, to Deposit Account Number 502650.

CERTIFICATE OF TRANSMISSION

I hereby certify that this correspondence is being facsimile transmitted to the USPTO or deposited with the United States Postal Service with sufficient postage as either First Class Mail or Express Mail, in an envelope addressed to the Commissioner for Patents.

Signed: Katrina Prati

Typed Name: Katrina Prati

Date: 4-1-05

Respectfully Submitted,



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Substitute for form 1449A/PTO				Complete if Known	
INFORMATION DISCLOSURE STATEMENT BY APPLICANT <i>(use as many sheets as necessary)</i>					
Sheet	1	of	7	Attorney Docket Number	P122-64V58

FOREIGN PATENT DOCUMENTS								
Examiner Initials*	Cite No. ¹	Foreign Patent Document			Name of Patentee or Applicant of Cited Document	Date of Publication of Cited Document MM-DD-YYYY	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	T ⁶
		Office ³	Number ⁴	Kind Code ⁵ (if known)				
E1	5,414,514			Smith et al.	5/9/1995			
E2	5,808,742			Everett et al.	9/15/1998			
E3	6,088,103			Everett et al.	7/11/2000			
E4	6,137,562			Masuyuki et al.	10/24/2000			
E5	6,391,217	B2		Schaffer et al.	5/21/2002			
E6	6,522,411	B1		Moon et al.	2/18/2003			
E7	2004/0007799	A1		Choi et al.	1/15/2004			
E8	2004/0021254	A1		Sreenivasan et al.	2/5/2004			
E9	2004/0021866	A1		Watts et al.	2/5/2004			
E10	2004/0022888	A1		Sreenivasan et al.	2/5/2004			
E11	2003/0092261	A1		Kondo et al.	5/15/2003			
E12	2003/0179354	A1		Araki et al.	9/25/2003			
E13	2002/0177319	A1		Chou	11/28/2002			
E14	2002/0150398	A1		Choi et al.	10/17/2002			
E15	2004/0008334	A1		Sreenivasan et al.	1/15/2004			
E16	2004/0009673	A1		Sreenivasan et al.	1/15/2004			
E17	2004/0124566	A1		Sreenivasan et al.	7/1/2004			
E18	2004/0089979	A1		Rubin	5/13/2004			

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E19	2004/0086793	A1	Sreenivasan et al.	5/6/2004		
E20	2004/0053146	A1	Sreenivasan et al.	3/18/2004		
E21	3,783,520		King	1/8/1974		
E22	6,150,231		Muller et al.	11/21/2000		
E23	6,489,068	B1	Kye	12/3/2002		
E24	6,646,662	B1	Nebashi et al.	11/11/2003		
E25	6,770,852	B1	Stegner	8/3/2004		
E26	6,776,094	B1	Whitesides et al.	8/17/2004		
E27	4,600,309		Fay	7/15/1986		
E28	4,848,911		Uchida et al.	7/18/1989		
E29	5,074,667		Miyatake	12/24/1991		
E30	5,148,036		Matsugu et al.	9/15/1992		
E31	5,148,037		Suda et al.	9/15/1992		
E32	6,518,189	B1	Chou	2/11/2003		
E33	2002/0132482	A1	Chou	9/19/2002		
E34	2002/0167117	A1	Chou	11/14/2002		
E35	6,482,742	B1	Chou	11/19/2002		
E36	2003/0080471	A1	Chou	5/1/2003		

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E37		2004/0036201	A1	Chou et al.	2/26/2004	
E38		2004/0192041	A1	Jeong et al.	9/30/2004	
E39		6,828,244	B2	Chou	12/7/2004	
E40		6,809,356	B2	Chou	10/26/2004	
E41		5,737,064		Inoue et al.	4/7/1998	
E42		2002/0018190	A1	Nogawa et al.	2/14/2002	
E43		2004/0197843	A1	Chou et al.	10/7/2004	
E44		2004/0156108	A1	Chou et al.	8/12/2004	
E45		2004/0137734	A1	Chou et al.	7/15/2004	
E46		2004/0131718	A1	Chou et al.	7/8/2004	
E47		2004/0118809	A1	Chou et al.	6/24/2004	
E48		2004/0046288	A1	Chou	3/11/2004	
E49		2003/0080472	A1	Chou	5/1/2003	
E50		2003/0034329	A1	Chou	2/20/2003	
E51		2002/0042027	A1	Chou et al.	4/11/2002	
E52		6,636,311	B1	Ina et al.	10/21/2003	
E53		6,383,888	B1	Stirton	5/7/2002	
E54		2004/0033515	A1	Cao et al.	2/19/2004	

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Sheet	4	of	7	Attorney Docket Number	P122-64V58

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		Office ³	Number ⁴	Kind Code ⁵ (if known)	Name of Patentee or Applicant of Cited Document	T ⁶
E55	5,999,245			Suzuki	12/7/1999	
E56	2004/0223131	A1		Choi et al.	11/11/2004	
E57	6,630,410	B2		Trapp et al.	10/7/2003	
E58	6,580,172	B2		Mancini et al.	6/17/2003	
E59	10/999,898			Cherala et al.	11/30/2004	
E60	4,512,848			Deckman et al.	4/23/1985	
E61	6,388,755	B1		Zhao	5/14/2002	
E62	6,295,120	B1		Miyatake	9/25/2001	
E63	6,049,373			Miyatake	4/11/2000	
E64	6,285,439	B1		Miyatake	9/4/2001	
E65	6,791,669	B2		Poon	9/14/2004	
E66	6,517,995	B1		Jacobenson et al.	2/11/2003	
E67	4,256,829			Daniel	3/17/1981	
E68	2004/0110856	A1		Young et al.	6/10/2004	
E69	5,028,366			Harakal et al.	7/2/1991	
E70	5,601,641			Stephens	2/11/1997	
E71	5,849,209			Kindt-Larsen et al.	12/15/1998	
E72	5,849,222			Jen et al.	12/15/1998	

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Substitute for form 1449A/PTO				<i>Complete if Known</i>	
INFORMATION DISCLOSURE STATEMENT BY APPLICANT <i>(use as many sheets as necessary)</i>				APPLICATION NUMBER	10/735,110
				FILING DATE	12/12/2003
				FIRST NAMED INVENTOR	Nimmakayala et al.
				Group Art Unit	2851
				Examiner Name	Unassigned
Sheet	5	of	7	Attorney Docket Number	P122-64V58

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Sheet		6	of	7	

OTHER PRIOR ART - NON PATENT LITERATURE DOCUMENTS

Examiner Initials*	Cite No. ¹	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T ²
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E83	Colburn et al., Step and Flash Imprint Lithography for sub-100 nm Patterning, Proceedings of SPIE Vol. 3997, pp. 453 - 457, 1/1/2000	
E84	Heidari, Nanoimprint Lithography at the 6 in. Wafer Scale, J. Vac. Sci. Technol. B 18(6), pp. 3557 - 3560, 11/1/2000	
E85	Martin et al., Predication of Fabrication Distortions in Step and Flash Imprint Lithography Templates, Journal of Vacuum Science Technology B 20(6), pp. 2891-2895, 11/1/2002	
E86	White et al., Novel Alignment System for Imprint Lithography, J. Vac. Sci. Technol. B 18(6), pp. 3552 - 3556, 11/1/2000	
E87	Translation of Japanese Patent 02-92603	
E88	Translation of Japanese Patent 02-24848	
E89	Chou et al., Ultrafast and Direct Imprint of Nanostructures in Silicon, Nature, Col. 417, (June 2002), pp. 835-837, 6/1/2002	
E90	Chou et al., Nanoimprint Lithography, Journal of Vacuum Science Technoloy B 14(16), pp. 4129-4133, 11/1/1996	
E91	Colburn et al., Development and Advantages of Step-and-Flash Lithography, Solid State Technology, 7/1/2001	

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Sheet		7	of	7													
<table border="1" style="width: 100%; border-collapse: collapse;"> <tr> <td style="width: 15%;">APPLICATION NUMBER</td> <td>10/735,110</td> </tr> <tr> <td>FILING DATE</td> <td>12/12/2003</td> </tr> <tr> <td>FIRST NAMED INVENTOR</td> <td>Nimmakayala et al.</td> </tr> <tr> <td>Group Art Unit</td> <td>2851</td> </tr> <tr> <td>Examiner Name</td> <td>Unassigned</td> </tr> <tr> <td>Attorney Docket Number</td> <td>P122-64V58</td> </tr> </table>						APPLICATION NUMBER	10/735,110	FILING DATE	12/12/2003	FIRST NAMED INVENTOR	Nimmakayala et al.	Group Art Unit	2851	Examiner Name	Unassigned	Attorney Docket Number	P122-64V58
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E92	Colburn et al., Characterization and Modeling of Volumetric and Mechanical Properties for Step and Flash Imprint Lithography Photopolymers, Journal of Vacuum Science Technology, Vol b. 19(6), 11/1/2001	
E93	Bailey et al., Step and Flash Imprint Lithography: Defect Analysis, Journal of Vacuum Science, B 19(6), pp. 2806-2810, 11/1/2001	
E94	Bailey et al., Step and Flash Imprint Lithography: Template Surface Treatment and Defect Analysis, Journal of Vacuum Science, B 18(6), pp. 3572-3577, 11/1/2000	
E95	Wronosky et al., Wafer and Reticle Positioning System for the Extreme Ultraviolet Lithography Engineering Test Stand, Emerging Lithography Technologies, Proceedings of SPIE Vol. 3997, pp. 829-839, 7/1/2000	
E96	Schneider et al., Stripes of Partially Fluorinated Alkyl Chains: Dipolar Langmuir Monolayers	

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